

#3P
RC
2/2/01

PATENT

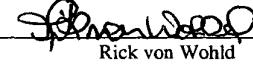
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:) Docket No: LAM1P077A
Kuthi, et al.)
Application No: Unknown) Group Art Unit: Unknown
Filed: July 6, 2000)
For: METHOD FOR MAKING A SEMICONDUCTOR) July 6, 2000
PROCESS CHAMBER ELECTRODE (As amended))

)

CERTIFICATE OF EXPRESS MAILING

I hereby certify that this paper and the documents and/or fees referred to as attached therein are being deposited with the United States Postal Service on July 6, 2000 in an envelope as "Express Mail Post Office to Addressee" service under 37 CFR § 1.10, Mailing Label Number **EL563119243US**, addressed to the Assistant Commissioner for Patents, Washington, DC 20231.


Rick von Wohld

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

The following is a preliminary amendment amending the specification and claims. Please enter the following amendments and remarks:

IN THE TITLE

Please amend the title as follows:

Please change the title from "Semiconductor Process Chamber Electrode and Method for Making the Same" to --Method for Making a Semiconductor Process Chamber Electrode--.